

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of Hideya TAKEO, et al.

Docket No: Q77911

Appln. No.: 10/684,708

Group Art Unit: 2624

Confirmation No.: 3651

Examiner: Sean T. MOTSINGER

Filed: October 15, 2003

For: ABNORMAL PATTERN CANDIDATE DETECTION PROCESSING METHOD AND  
SYSTEM

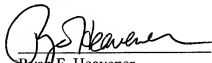
**STATEMENT UNDER 37 C.F.R. § 1.704(d)**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was first cited in a communication from a foreign patent office in a counterpart foreign application, and that the communication was not received by any individual designated in 37 C.F.R. § 1.56(c) more than thirty days prior to the filing of said Information Disclosure Statement.

Respectfully submitted,

  
Ryan F. Heavener  
Registration No. 61,512

SUGHRUE MION, PLLC  
Telephone: (202) 293-7060  
Facsimile: (202) 293-7860

WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: July 23, 2008